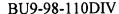
11-21-00



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re divisional patent application of

D. Armbrust et al

Serial No.: Unassigned

Group Art Unit:

Unknown

Filed:

Concurrently Herewith

Examiner:

Unknown

For:

SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED

ADHESION/ELECTROMIGRATION

Assistant Commissioner of Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicants' duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. All of these references were either cited or submitted in parent Application No. 09/298,796 and thus copies of these references are not provided in accordance with 37 C.F.R. §1.98(d).

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicants are aware.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

BU9-98-110DIV

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 09-0456.

Respectfully submitted,

Frederick W. Gibb, III Registration No.: 37,629

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